# A model to interpret the desorption of H and D from graphite

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## Simulations of MBE experiments

Growth of atomic species adsorbed on surfaces is mainly governed by random processes.

desorption

diffusion

Exchange between adsorbate and substrate atoms

deposition

aggregation

## Ingredients in KMC and assumptions

- 1. Deposition is governed by the flux F (ML/s).
- Monomers H or D
- Monoenergetic  $E_{incident} = E_i$  (the most probable in M.B. distribution)



on the surface, the impinging H (D) has to jump over the adsorption barrier E<sub>a</sub> with a probability described by an Arrhenius law
E<sub>A</sub> is site dependent (monomer or dimers)

## KMC ingredients and assumptions

2. Diffusion and Desorption are governed by Arrhenius law

depend on prefactors fixed by the relation

$$V_{D=}V_{E=}\frac{kT_m}{h}$$

Depend on barriers calculated from DFT

$$P_{D,E} = V_{D,E} e^{-\frac{E_{D,L}}{kT}}$$

3. The detection of evaporated species : We consider only particles which leave the surface



Several hypotheses which have a practical use in KMC to simplify discussion, but which can strongly influence the results when compared to experiments.

See Cupen and Hornekaer (J. Chem. Phys. 2008)

# What is known about this topic

## **TDS** experiments

H or D coverage vs exposure at T=150K and F=10<sup>-2</sup> MLs<sup>-1</sup> Sticking =0.4±0.2

•The desorption spectrum exhibits two peaks at 500 and 570 K with an isotopic dependence which is different for the two peaks (Zecho et al., JCP 117, 8486 (2002))



### STM data

para and ortho dimers play a crucial role, their behavior with T can interpret the two peaks occurrence (Hornekaer et al., PRL 96, 156104; 97 186102 (2006))

•calculations for the barrier values (Jeloaica et al CPL 300, 157 (1999), Rougeau et al; CPL 431, 135 (2006), Ferro et al JCP 116, 8124 (2002), 120, 1182 (2004), Hornekaer et al. )

DFT



Monomer adsorption (1) and desorption  $(\downarrow)$ 

### The adsorption process in our KMC

 $\forall \Delta E = E_A - E_i$  governs the adsorption at low coverage ( $\theta < 0.2$  ML)

• $E_A$ =0.18 eV for the monomer and orthodimer,  $E_A$ =0 for the paradimer and  $E_A$  =0.2 eV for the metapair  $\rightarrow E_i$ =0.17 eV to be consistent with sticking experiments.

•The proportion of monomers and dimers on the surface is sensitive to the various  $\Delta E$  (adsorption of a monomer atom, adsorption in dimer configurations)



# Diffusion and desorption : Competitive processes ?

KMC snapshots of 0.1 ML of H atoms deposited with E<sub>i</sub>=0.17 eV show :
At 400 K, no monomer, mainly para and ortho dimers coexist

in the ratio <sup>1</sup>/<sub>2</sub>

•At 540 K, only ortho dimers are observed



•Two peaks occur in the coverage loss (MI s-1) for 400<T<600 K



•For 450<T<530 K, orthodimers are stable while paradimer desorption proceeds according to 3 paths

- •Evaporation of one H in the pair ( $E_{EE}$ =1.62 eV)
- •Diffusion of one H toward meta or 5 ( $E_D = 1.67$  or 1.79 eV)
- •Direct evaporation (E<sub>E</sub>=1.40 eV) : the main efficient path !
- For T>530 K, competition between reaction paths leading to the occurrence of the second peak around 570 K
  - Direct evaporation of one H in the orthopair ( $E_e=1.67 \text{ eV}$ ) followed by the evaporation of the remaining monomer ( $E_e=0.87 \text{ eV}$ )
  - ii) Diffusion of one H toward meta (E<sub>E</sub>=1.63 eV) followed by diffusion toward para (0.46 eV) and evaporation of the newly formed parapair
  - iii) Diffusion of one H toward meta ( $E_D$ =1.63 eV), followed by evaporation of one H of the metapair ( $E_E$ =0.79 eV) and evaporation of the remaining monomer
  - iv) Diffusion of one H toward meta ( $E_p$ =1.63 eV) followed by diffusion from meta to ortho ( $E_p$ =0.46 eV) to recover the initial situation

#### Diffusion and desorption : Competitive processes ?



Large monomer diffusion in the three paths ii), iii), iv)

Presence of parapairs due to the diffusion, though they disappear below 530 K

Resulting scenario : 18% of path i)) ; 41% to each of paths ii) and iv) contributions to the orthodimer disappearence on the surface

#### Diffusion and desorption processes : influence of isotopic change

**TDS experiments :** 

•H : two peaks at 445 and 560 K

•D : two peaks at 490 and 580 K

$$\Delta T_1 = 45 \text{ K}$$
,  $\Delta T_2 = 20 \text{ K}$ 

Simulations:

Initial barriers E<sub>E,D</sub> become effective barriers

$$E_{D,E}^* = E_{D,E} - \frac{1}{2} \sum_{s} \Box \omega_{s}$$

 frequencies are issued from EELS (Zecho et al) and from lattice dynamics calculations (Morisset et al, J. Chem. Phys. 2008)

Barrier to	Initial	H -	D
Para pair desorption	1.4	1.08	1.20
Ortho monomer desorption	1.67	1.34	1.47
Diffusion ortho to meta	1.63	1.52	1.55

- The new barriers are too low !
- ΔT is the same for the 2 peaks

Diffusion and desorption processes : influence of isotopic change

A solution to this discrepancy with experiments

The fisrt peak is well interpreted for both H and D

The second peak is due to different desorption processes for H and D

Barrier to	Initial		D
Para pair desorption	1.56	1.23	1.36
Ortho monomer desorption	1.91	1.58	1.71
Diffusion ortho to meta	1.72	1.61	1.64

With these new barriers, the second peak is due to • for H, a competition between desorption of H orthodimer and its diffusion to meta dimer. Two likely probable processes • For D, the diffusion from ortho to meta dimer is largely.

•For D, the diffusion from ortho to meta dimer is largely favored

#### Diffusion and desorption processes : influence of isotopic change



We find a nice agreement with experiments  $\Delta T_1 = 38 \text{ K}$  $\Delta T_1 = 25 \text{ K}$ 

# Rate equations approach

More flexible than KMC

Allows to study larger coverage (trimers) to interpret high temperature shoulder of the main peak

System of coupled equations

-densities of sprecies n<sub>x</sub>,X=1,5,P,M,O,T

-efficiency of processes A<sub>x</sub>,D<sub>xy</sub>,E<sub>x</sub>,E<sub>xx</sub>

-number of equivalent configurations

-number of trimers formed from a dimer gY (Y=P,M,O)

-coverage  $\theta = n1 + 2(n_5 + n_p + n_M + n_O) + 3n_T$  $\frac{dn_1}{dt} = A_1(1 - \alpha \theta) - (6A_5 - 3A_p - 6A_M - 3A_O)n_1 + 2(\sum_{X \neq 1,T} n_X E_X - n_1 E_1) - 18D_{15}n_1^2 + 6D_{51}n_5$   $\frac{dn_5}{dt} = (6A_5 - 3D_{51} - D_{5p})n_5 - 2n_1 E_5 + 9D_{15}n_1^2 + 2D_{p5}n_p$   $\frac{dn_p}{dt} = (3A_pn_1 + D_{5p}n_5 + 2D_{Mp}n_M) - (2E_p + E_{pp} + 2D_{p5} + 4D_{pM})n_p + g_p(3n_T E_T / \sum_{Y} g_Y - n_p A_T)$   $\frac{dn_M}{dt} = (6A_Mn_1 + 4D_{PM}n_p + 4D_{OM}n_O) - 2(E_Mn_M + D_{MP}n_M + D_{MO}n_p)$   $+ g_M(3n_T E_T / \sum_{Y} g_Y - n_M A_T)$   $\frac{dn_o}{dt} = (3A_on_1 + 2D_{MO}n_M) - (2E_o - E_{po} - 4D_{OM})n_O$   $+ g_O(3n_T E_T / \sum_{Y} g_Y - n_O A_T)$   $\frac{dn_r}{dt} = (g_OA_T - 3E_T)n_T + g_M A_T n_M + g_P A_T n_P$ 

# Rate equations approach

The corresponding coverage loss for H and D, including the presence of trimers

Nice agreement with experiments

No picture here....please believe us or try to find our stolen notebook !

#### **Conclusion**:

-We are aware that our approach is oversimplified and that some hypotheses should be removed

-This problem is still largely opened (more accurate experiments and DFT informations)